

IMRAA.013DV



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Jiang et al.) Group Art Unit 2881
Appl. No. : 09/738,372)
Filed : December 15, 2000)
For : RESONANT FABRY-PEROT)
SEMICONDUCTOR)
SATURABLE ABSORBERS)
AND TWO-PHOTON)
ABSORPTION POWER)
LIMITERS)
Examiner : Zahn, J.)

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AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

This is a response to the Office Action mailed on 5/22/01 in which all of the claims pending in this application were rejected under 35 USC § 112 and 35 USC § 103. Claims 22-28 and 33-34 are pending in this application, and reconsideration of the Examiner's rejection is solicited based on the remarks which follow.

In the claims:

Please amend Claim 27 as follows:

27. (Amended) A method as defined in Claim 26, wherein said generating step additionally comprises resonating said [light] optical radiation within said Fabry-Perot structure.